

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/539,571

Applicants: Toru KIMURA, et al.

Filing Date: June 17, 2005

For: VACUUM CONTAINER APPARATUS USED FOR
MANUFACTURING SEMICONDUCTOR DEVICES AND LID
APPARATUS FOR SAME.

Group Art Unit: 3781

Examiner: Robin HYLTON

SIR:

Attached hereto for filing are the following papers:

INTERVIEW SUMMARY STATEMENT

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of **\$0.00** to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. **15-0030**. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

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